

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS:	FORREST, et al.	CONFIRMATION NO.	5397
SERIAL NO.:	10/581,622	GROUP ART UNIT:	1794
FILED:	June 5, 2006	EXAMINER:	Lawrence D. Ferguson
FOR:	FREE-STANDING SILICON CARBIDE ARTICLES FORMED BY CHEMICAL VAPOR DEPOSITION AND METHODS FOR THEIR MANUFACTURE		

ATTORNEY DOCKET NO.: 52993/326894
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Commissioner for Patents
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CERTIFICATE OF ELECTRONIC TRANSMISSION

I hereby certify that this correspondence is being filed with the
United States Patent and Trademark Office via EFS Web on
November 5, 2008.

/lisa norris/
Lisa Norris

AMENDMENT AND RESPONSE

Sir:

In response to the Office Action of August 5, 2008, Applicants respectfully submit the following amendments and remarks in connection with this application.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 5 of this paper.

The **Decision on Petition** dated July 19, 2006 is attached at the end of this paper.

Materials relating to "Moissanite-3C silicon carbide" are attached at the end of this paper.